

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

## **Patent Application**

Applicant(s): Z. Xie et al.

Case:

3-4

Serial No.:

10/623,983 July 21, 2003

Filing Date: Group:

2826

Examiner:

Fetsum Abraham

Title:

Shielding Structure for Use in a Metal-Oxide-Semiconductor Device

Alexandria VA 22313-1450.

## AMENDMENT AFTER FINAL REJECTION UNDER 37 C.F.R. §1.116

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 Please enter.
- Evan Pert
9-18-06

I hereby certify that this paper is being deposited on this date with the U.S. Postal

Service as first class mail addressed to the Commissioner for Patents, P.O. Box 1450,

Sir:

In response to the final Office Action dated November 17, 2005, Applicants submit herewith the following Amendment for entry in the above-identified application:

02/23/2006 MAHMED1 00000009 500762 200.00 DA 01 FC:1201